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Application Number Filing Date		09988320 2001-11-16		
First Named Inventor Fran		ncis M. Lacan		
Art Unit		2136		
Examiner Name	David	G. Cervetti		
Attorney Docket Number	er	CHA920010022US1		
/	First Named Inventor Art Unit Examiner Name	First Named Inventor France Art Unit Examiner Name David		

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